

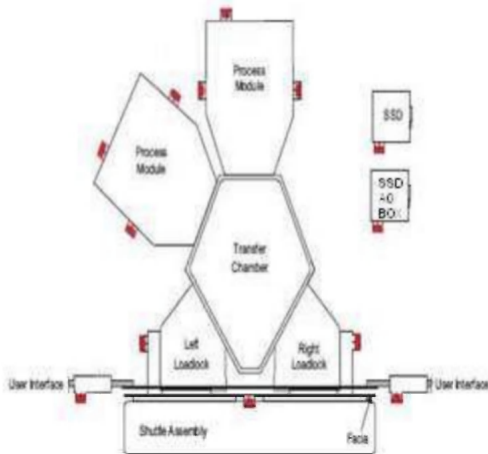
# Novellus C2 ALTUS Configuration

Customer Name :   Form : System Audit

## Order Information

MIC NAME	C2 altus	Source Inspection		Machine Type:	Shrink
Auditor:	SYSTA			Serial Number:	
				DLCM & CH1 :	98- 12- 5490
				CH2 :	00- 10- C25490

## System Diagram

<b>Wafer Size</b>	<b>Wafer Shape</b>	<b>SMIF Interface</b>	<b>Aligner Option</b>	<b>System Main Power</b>		
200mm	Notch	No	yes	3 @ 5Wires 208V		
Shrink				System UPS Power		
Chamber A pump				SSD AC BOX	YES	30 5Wires 208V
Module B				Shuttle Type	Wide	Loadlock Dry Pump
Chamber B pump				TM Dry Pump	YES	Slit Valve Type
TM Robot Type				TM Throttle Valve Model	MKS	SMC □-Motion
TM Robot Blade	Wafer sensor	Fab Installation	EMO's Type	Loadlock Baratron Model		
Metal	Existence	YES	Turn to Release	MKS		
	Signal Tower	Module Controller		TM Baratron Model		
	Yes	MC3		MKS		
				Front Monitor		
				12" LCD		

## System Information

**System Notes:**

\* system power off ※작업중

### Module A Information

Chamber Type

**Shrink**

MOER Size

**N/A**

Manometer 1(1 OT)

**Millipore CDLD1106E**

Manometer 2(100T)

**MilliporeCDLD2106E**

Manometer 2(100T)

**Millipore CDLD2106E**

Module Controller

**MC3**

Throttle Valve

**Millipore MDVX100B**

MFC STATUS

**Good**

LF Generator

**AE RFG3000**

RF Match

**TrazarAMU2-1**

MOER Option

**Yes**

Module Dry Pump

**YES**

Pedestal Pump

**YES**

Module A Notes:

### Module B Information

Chamber Type

**Shrink**

MOER Size

**N/A**

Manometer 1(1 OT)

**MilliporeCDLD1106E**

Manometer 2(100T)

**MilliporeCDLD2106E**

Manometer 2(100T)

**MilliporeCDLD2106E**

Module Controller

**MC3**

Throttle Valve

**MilliporeMDVXI00B**

MFC STATUS

**Good**

LF Generator

**AE RFG3000**

RF Match

**TrazarAMU2-1**

MOER Option

**Yes**

Module Dry Pump

**Yes**

Pedestal Pump

**Yes**

Module B Notes: